



**ELECTRONIC COPY**

LG652434844  
Report verification at igi.org



September 14, 2024

IGI Report Number **LG652434844**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **11.58 X 8.44 X 5.70 MM**

**GRADING RESULTS**

Carat Weight **4.88 CARATS**

Color Grade **F**

Clarity Grade **VS 1**

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**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

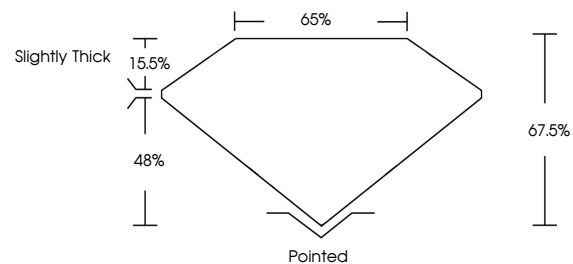
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG652434844**

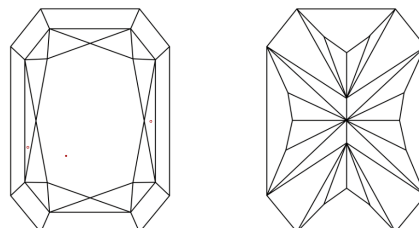
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

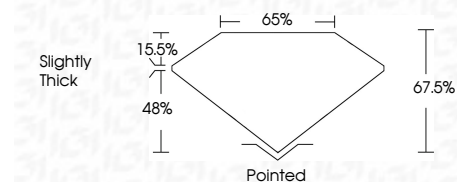
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**IGI**



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IGI Report No. LG652434844  
CUT CORNERED RECT. MODIFIED BRILLIANT

4.88 CARATS  
F

11.58 X 8.44 X 5.70 MM

Color Grade VS 1  
Depth 67.5%  
Table 65%  
Girdle Slightly Thick

Culet Pointed  
Polish EXCELLENT  
Symmetry EXCELLENT  
Fluorescence NONE  
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